

<b>Notice of References Cited</b>	Application/Control No.	Applicant(s)/Patent Under Reexamination	
	10/027,604	FERNANDO, CHENJING	
	Examiner Hwa C Lee	Art Unit 2672	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-4,592,077 /	05-1986	Norton, Jerry J.	375/360
B	US-6,571,185 /	05-2003	Gauland et al.	702/68
C	US-6,311,138 -	10-2001	Miller, Martin T.	702/67
D	US-6,525,525 /	02-2003	Azinger, Frederick A.	324/121R
E	US-6,621,913	09-2003	de Vries, Johan	382/100
F	US-5,495,168 /	02-1996	de Vries, Johan	324/121R
G	US-6,556,202 -	04-2003	Taraki et al.	345/440.1
H	US-2001/0001850 /	05-2001	Miller, Martin T.	702/67
I	US-6,448,913 /	09-2002	Prucnal et al.	341/137
J	US-2003/0011839 /	01-2003	Liang et al.	359/124
K	US-2003/0063696 /	04-2003	Tuyl, Rory Van	375/354
L	US-2003/0156655 /	08-2003	Hietala et al.	375/293
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
Q					
R					
S					
T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.